

SEP 11 2007

0008-FA-US

09/748,714

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Hunt et al.)	
)	Art Unit: 1762
Serial No. 09/748,714 conf. No. 4539)	
)	Examiner: David P. Turocy
Filed: 21 December 2000)	
)	
For: CHEMICAL VAPOR DEPOSITION))	
METHODS FOR MAKING)	
POWDERS AND COATINGS,)	
AND COATINGS MADE USING)	
THESE METHODS)	

AMENDMENT IN RESPONSE TO OFFICE ACTION DATED 22 JUNE 2007

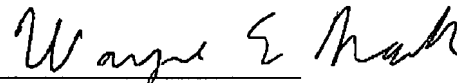
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of 22 June 2007, please amend the application by canceling Claim 101 and amending Claim 102 to make Claim 102 dependent from allowed Claim 1. Claims 103 and 104 depend from Claim 102 and thus from allowed Claim 1. Claim 104 is amended to put "micron" in the singular". The remaining pending claims, 1-4, 6-33, 99 and 100 are allowed. Prompt passage of this application to issue is requested.

Respectfully Submitted,

31 August 2007


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